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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No	10/614,807
Filing Date	
Inventor	
Assignee	
Group Art Unit	
Examiner	
Attorney's Docket No	H0004116-US
Title: Copper Sputtering Targets and Me	ethods of Forming Copper Sputtering
Targets	

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

A check in the amount of \$180.00 is enclosed to cover the fee specified under 37 C.F.R. § 1.17(p).

Respectfully submitted,

Datad:

Bv:

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180.00 OP

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in

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EXAMINER

DATE CONSIDERED

conformance and not considered. Include copy of this form with next communication to applicant.